

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Akira SUZUKI *et al.*

Serial No.: 10/784,888

Filing Date: February 24, 2004

For: MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE WITH  
CHAMFERING (as amended)

Examiner: Bradley Smith

Group Art Unit: 2891

Confirmation No.: 9967

**AMENDMENT UNDER 37 CFR 1.111**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed August 7, 2007, please amend this application as follows.

**The listing of claims begins on page 2.**

**Remarks begin on page 6.**